



S/N 09/909,532

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kie Y. Ahn et al.

Examiner: Maria Guerrero

Serial No.: 09/909,532

Group Art Unit: 2822

Filed: July 20, 2001

Docket No.: 303.377US3

Title: POROUS SILICON OXYCARBIDE INTEGRATED CIRCUIT INSULATOR

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This paper responds to the Office Action mailed on September 16, 2003. Please amend the above-identified patent application as follows.

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a three-month extension of the period for responding to the Office Action, thereby moving the deadline for response from December 16, 2003 to March 16, 2004.